

**IN THE SPECIFICATION:**

Please amend the two paragraphs beginning at line 6, page 1 of the specification, as follows.

This application is a continuation-in-part of a pending patent application entitled, METHODS FOR FABRICATING OXIDE THIN FILMS, invented by Joshi et al., Serial No. 10/801,374 [[\_\_\_\_]], filed March 15, 2004 [[\_\_\_\_]], Attorney Docket No. SLA787.

This application is a continuation-in-part of a pending patent application entitled, DEPOSITION OXIDE WITH IMPROVED OXYGEN BONDING, invented by Pooran Joshi, Serial No. 10/801,377 [[\_\_\_\_]], filed March 15, 2004 [[\_\_\_\_]], Attorney Docket No. SLA766.